The invention relates to agriculture, namely to a process for mass rearing of entomo-phage *Trichogramma* evanescens W.

The process, according to the invention, provides for the sterilization of *Sitotroga cerealella* O. grain moth eggs by treating them for 4...5 min with infrared rays with a wavelength of 750...1000 nm from a source with a power of 250 W, situated at a distance of 250...300 mm from the eggs placed in a layer, their subsequent maintenance at the temperature of 23...25°C and relative humidity of 75...85% for 5...7 days, separation of sterile eggs and rearing of entomophage with their use.

Claims: 1